



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant:	John Steffen et al.)	Examiner:	Unassigned
Serial No.:	10/798,041)	Group Art Unit:	1772
Filed:	March 11, 2004)	Confirmation No.	4963
For:	Apertured Film With Raised Profile Elements, Method Of Making The same, And The Products Thereof)		

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Attached Form PTO/SB/08A lists references which may be considered to be material to the above-identified application by the Patent Examiner. Entry into the record is respectfully requested.

Respectfully submitted

By

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CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage at First Class Mail in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on **July 6, 2004**



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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Application Number	10/798,041
				Filing Date	March 11, 2004
				First Named Inventor	John Steffen
				Group Art Unit	1772
				Confirmation No.	4963
				Examiner Name	Unassigned
Sheet	1	of	1	Attorney Docket No.	PGI6044P3011US

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US- 4,041,203	08/09/1977	R. Brock et al.	
		US- 4,381,326	04/26/1983	W. Kelly	
		US- 5,679,379	10/21/1997	A. Fabbriante et al.	
		US- 5,910,225	06/08/1999	L. McAmish et al.	
		US- 6,114,017	09/05/2000	A. Fabbriante et al.	
		US- H1,927	12/05/2000	Z. Chen et al.	
		US- 6,191,211	02/20/2001	R. Mussell et al.	
		US- 6,264,864	07/24/2001	J. Mackay	
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Examiner Signature				Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standards ST.16, if possible. ⁶ Applicant is to place a checkmark here if English language Translation is attached.